

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Wen-Jian Lin
Appl. No.	:	10/810,660
Filed	:	March 29, 2004
For	:	STRUCTURE OF A MICRO ELECTRO MECHANICAL SYSTEM AND THE MANUFACTURING METHOD THEREOF
Examiner	:	Jarrett J. Stark
Group Art Unit	:	2823

## SUPPLEMENTAL AMENDMENT

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to consideration of the fully responsive reply filed January 17, 2007, the Applicants respectfully request that the Examiner enter the following supplemental amendments.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.